

汎銓科技 半導體產業高階製程領航者

www.msscorps.com



MSSCORPS. (6830) 2025 Q1 Operations & Performance

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From MSS's Perspective

- ☐ With strong A⁰ designs, silicon photonics, AI related demand
- □ Customer groups for related applications in Compound `Wide Band Gap `CIS `H-V `Logic IC and memory facing China Cost Competition, demand "remains" sluggish.
- ☐ Global arrangement on 2024, not only no affected by tariff barriers but also benefited from overseas market revenue increased

MSS classification and growth

Item	Group	Technology	MSS niche	Description	2024 Revenue proportion	2025Q1 Revenue proportion	Expected growth in 2025-2026
Advanced processes (Angstrom era)	MA	DD:	3rd generation EUV PR protection technology	Metal oxide PR	(//	54.3%	
	MA	PR protection technology	Advanced EUV PR protection technology	EUV PR/etch structural analysis			
	MA	technology	Selective deposition sample preparation technology	Special ALD deposition			
	NAA	low-k protection	BEOL: low-k structure protection technology	AMAT announces black dimand materials	-		
		technology	BEOL: low-k damage analysis technology	Low-k composition analysis			
	MA		Novel 2D materials analysis method	Weak-bonding materials analysis	54.7%		
	MA	Ultra-thin sample method	Ultra-thin sample protection method	2nm/A14 device structural analysis	/		
	MA		FEOL: GAA etch byproduct bonding state analysis	2nm/A14 device composition analysis			7 \ /
	MA		MEOL: ALE etch byproduct comparison platform	-21111/A14 device composition analysis	SILIOH arialySIS		
	MA		High aspect ratio structural TEM analysis technology	DRAM cell analysis			
	MA	Auto-measurement	Artificial intelligence for automatic measurement	Massive/reliable/accurate measurements	.s		
	MA	ML ball height/ML	Optical component analysis technology: ML ball height/ML defect	CIS		9.4%	
	MA	defect	Wearable device AR/VR product lens integration analysis	Meta Lens/Pancake Lens			\ / \
	MA		Epitaxial defect quantitative analysis technology	GaN on Si	()		
Mature	MA	Compound Semiconductor	Carrier concentration distribution analysis in compound semiconductors	GaAs/InP/SiC	12.7%		
processes	MA	Semiconductor	Integrated stress analysis technology	PA amplification ability (diffraction pattern analysis)	12.7%		
processes	MA	OLED	Ultra-low contrast imaging technology for layer structures	Polymer image analysis	1		
	MA	CCL/FCCL	Soft material slicing technology	Non-curtain effect/void			
	MA		General materials analysis (SEM/FIB CS/Reversed MA/SIMS)	·			
	FA	Compound	High voltage and high temperature test (1000V, 300C)	GaN/SiC		_	
		Semiconductor	Ultrathin sample preparation technology for EFA	GaN/GaAs/SiC/3nm HPC InGaAs electrical measurem			
	FA		Signal lead technology				
IC failure	FA		Backside signal lead technology	Tapping wire to directly measure the single logic gate	0.00/	10.6%	
analysis	FA	Circuit edit	Adding external multiple passive components technology	Advanced process IC	9.8%		
ariarysis	FA	technology	Precise local RDL removal technology	Dedicated for WLCSP/FO IC			
	FA		Filpchip front side FIB technology	Flipchip IC			
	FA		General failure analysis (decap/delayer/electrical property/CRD/IC Reverse/SAT/3D Xray)		,p 10		
	MA	Silicon photonics structure	Large-area rapid cutting method for silicon photonics/Conductive preparation method for silicon photonics/Low-curtain effect cutting method for silicon photonics	Precise parallel lapping and PFIB to increase TEM capacity for silicon photonics		7.0%	
	FA	Structure	Light characteristics and attenuation detection for silicon photonics	On the silicon photonics testing platform, the emitted	1		1. /
	FA	Silicon photonics	Optical path abnormality positioning, circuit break, light leakage detection for silicon photon	light enters the silicon photonics IC, coupling to the	5.7%		
Silicon	FA	photoelectricity test	12-inch silicon photonic photometric platform with fully automatic light scanning	waveguide in the IC, and then passes through different functional components such as light			
photonics	MA	Advanced package	PFIB/hybrid metal bond/TSV	TEM for 3D IC bond alignment/junction oxide/TSV TEM			
	FA	A for advanced process chips 3nm delayer/um to nm positioning, direct nano probe measurements on devices Verified 3nm probe measurements on devices		Verified 3nm products			
	FA	Advanced package	Large IC packaging and carrier board separation technology/THZ-TDR open /Thermal xyz fau Patent protection/5um precise positioning				
Abroad		Special ALD coating/ultra-thin technology	Advanced photoresist protection/low-k structure protection/high depth and width TEM and other technologies		17.1%	18.7%	



Participate in the development of MOR (Metal oxide) EUV photoresist for next-generation high NA EUV exposure machine







Locations-Taiwan

- MA Center + Zhubei II : 1.4nm-A⁰ advanced process
- □ Headquarter: 「Silicon photonics testing and positioning analysis」
- ☐ Zhubei I: 「Al Customer Area」
- □ SAC-TEM Center will be opened before 2025/Q3
- □ Zhubei Ⅲ: We will planned to 「AI Customer Area」 & 「Silicon photonics testing and positioning analysis」 in 2026.



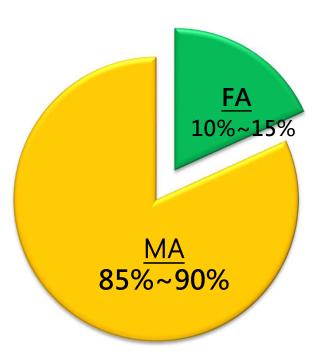
Locations-Worldwide

- ☐ MSS China: obtained of "High-tech Enterprise" and tax reduction and exemption policies
- ☐ MSS USA CORP. : The Lab in completion and the equipments acceptance phase and it will be opened in 2025/05
- ☐ MSS Japan: The Lab is still under construction and is expected to open in Q3 2025
- Invited by customer to establish operating base in Europe

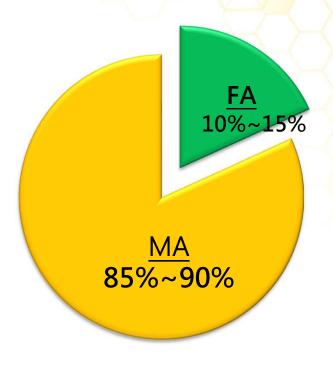


Product Portfolio

2024 Q1



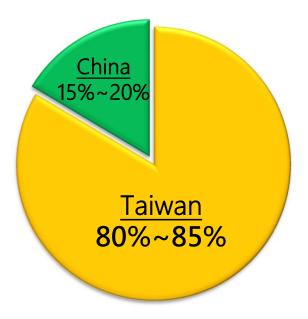
2025 Q1



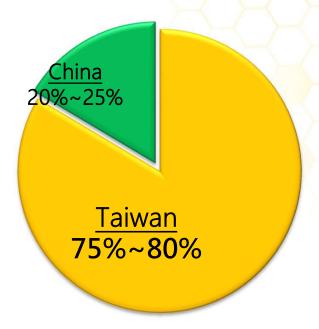


Marketing Mix

2024 Q1

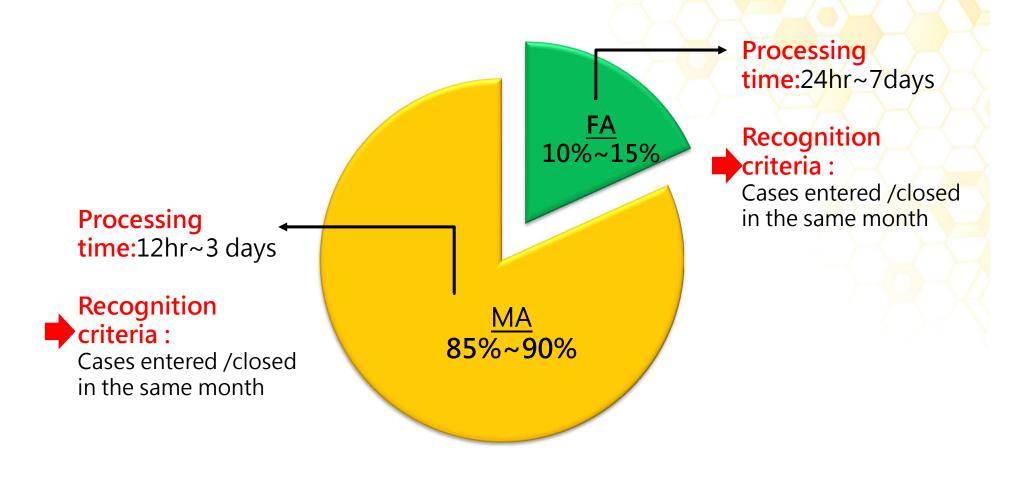


2025 Q1





2025Q1





Employees Trends

2024 VS 2025 Q1

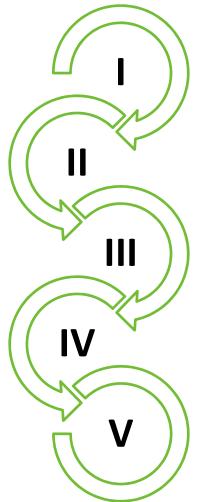
Quarter	Q1	Q2	Q3	Q4
2024	605	615	630	650
2025	680	-	-	-



Company Profile



About MSS



汎銓科技股份有限公司 MSSCORPS CO.,LTD.(abbr.MSS)

Founded: July 27,2005

Listing: August 31,2022

Chairman and CEO: Gino Liu

Capitalization: NTD518million

Number of Employees: 680

Service Item: MA(Materials Analysis)

FA(Failure Analysis)



MSS role in the semiconductor industry chain-FA

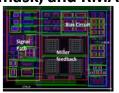
Positioning

Content

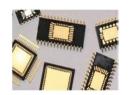
FA(Failure Analysis)

(Hospital of ICs)

IC design, mask, and RMA



Package/substrat e/PCB/FPC



Design debugging and failure root cause investigation are the keys to shorten time to market

- IC circuit repair for designers to find design bugs and confirm effectiveness of revised design
- FA method to find failure root cause of fail IC after mass production

MSS **low-damage methods** developed in MA can be extended to be utilized in back-end industry

- Material diversity, hardness difference, thinner layers, and weaker inter-layer force to cause difficulties for analysis
- Special methods to reduce heat- and electricity-induced artifacts

Flow chart











物性故障分析















修改後 驗證









MSS role in the semiconductor industry chain-MA

Positioning

Content

MA(Material s Analysis)

(R&D Pilot)



Wafer foundry/equipment /materials

Providing timely correct structural and chemical analyses of specimen of interest to Fab for

- New technology node R&D, to determine process parameters, new materials, and process tools
- Process tool consistency check during transfer from R&D to mass production
- Yield optimization in mass production





Statements of Comprehensive Income

(In NT\$ thousand)	114年Q1	113年Q1		
Revenue	464,693	434,851		
Gross profit	61,123	109,406		
Margin %	13	25		
Operating expenses	(109,025)	(91,481)		
Total non-operating income and expenses	(3,051)	(7,509)		
Profit before income tax	(50,593)	10,416		
Income tax expense	2,088	(19,979)		
Total non-operating income and expenses	(48,865)	(9,563)		
EPS	(0.94)	(0.20)		



Balance Sheet

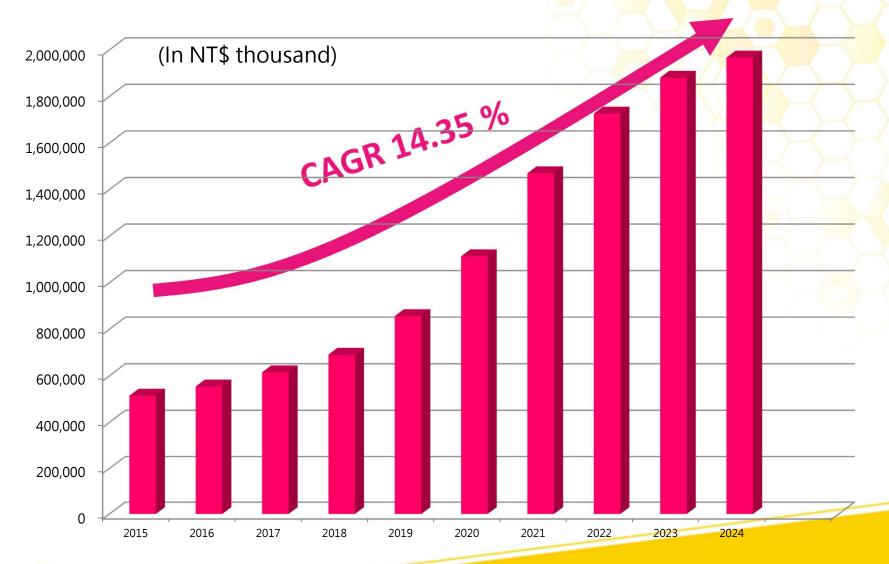
(In NT\$ thousand)	114/03/31 Amount %		113/03/31 Amount %	
Cash and cash equivalents	1,131,940	19%	713,736	15%
Trade receivables	666,498	11%	600,275	13%
Prepayments & Other assets	193,048	4%	141,200	3%
Property, plant and equipment	3,274,627	55%	2,410,914	52%
Right-of-use assets and other non- current assets	636,253	11%	791,336	17%
Total Assets	5,902,366	100%	4,657,461	100%
Short-term debt & current portion of long- term loans payable	240,667	4%	186,767	4%
Trade payables & Other payables	201,509	4%	393,415	8%
Other current liabilities	146,395	2%	345,302	8%
Convertible Bond	470,860	8%	-	-
Long-term borrowings	1,430,869	24%	1,106,082	24%
Other non-current liabilities	279,497	5%	244,660	5%
Total liabilities	2,769,797	47%	2,089,459	45%
Total equity	3,132,569	53%	2,568,002	55%

Cash Flows

(In NT\$ thousand)	114年Q1	113年Q1
Beginning Balance	1,181,200	622,110
Cash from operating activities	104,325	152,600
Capital expenditures	(259,438)	(404,176)
Proceeds from short-term &long-term debt	207,000	411,000
Long-term loans	(104,589)	(45,864)
Others	3,442	21,934
Ending Balance	1,131,940	713,736



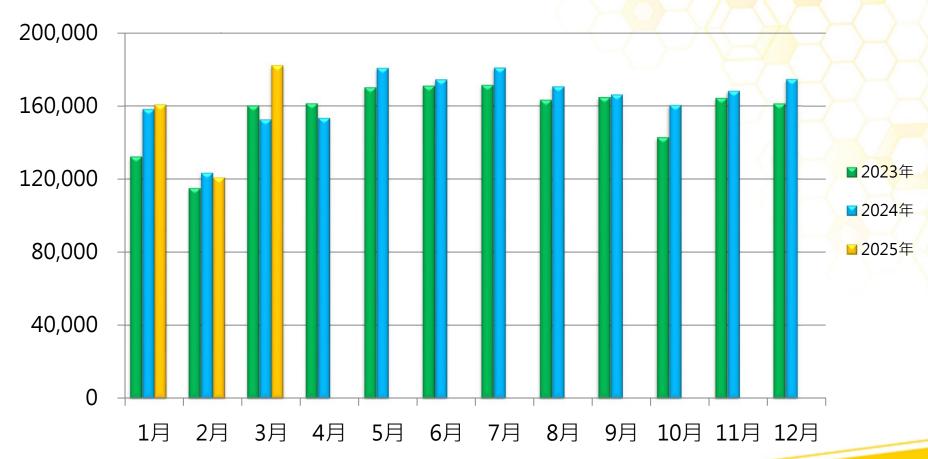
Revenue Compound Annual Growth Rate in the past ten years





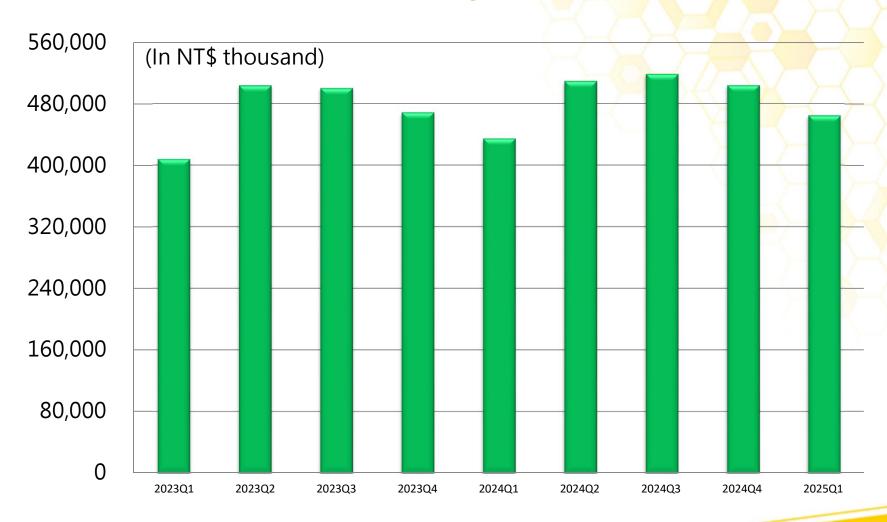
2023~2025 Monthly Revenue Trends

(In NT\$ thousand)



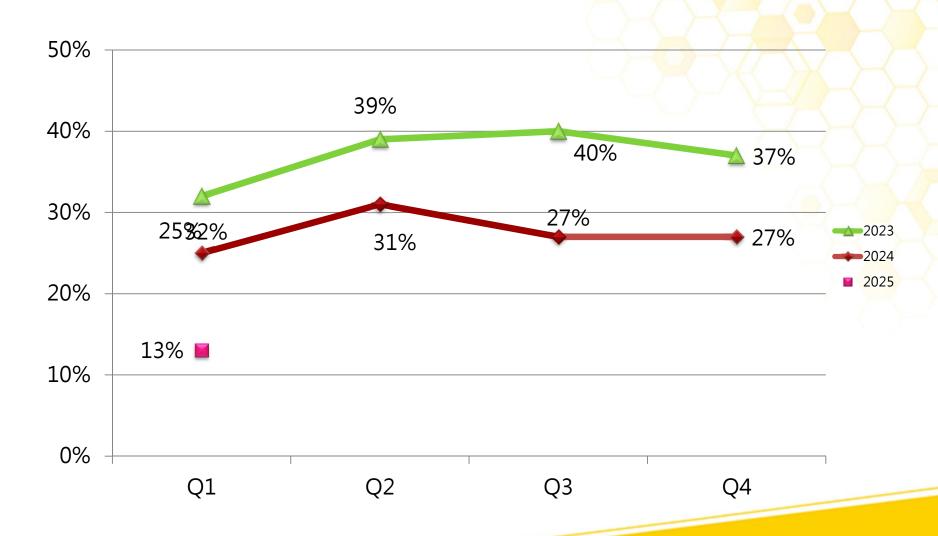


2022~2024 Quarterly Revenue Trends





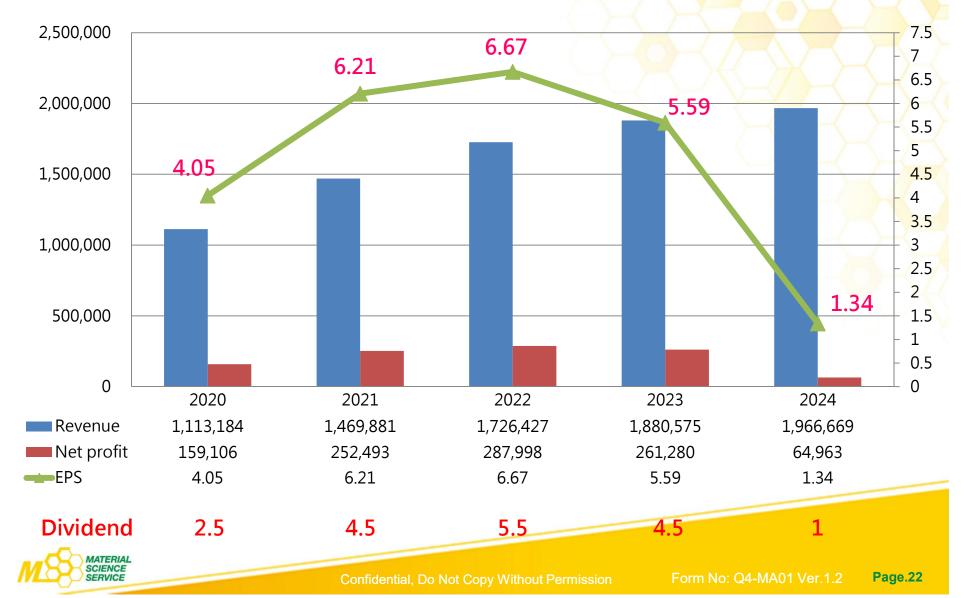
2022~2024 Quarterly Margin





Profitability & Dividend in the past five years

(In NT\$ thousand)



Thank you for listening.





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